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| Applicant | : Hiromi WATAYA | Group Art Unit : 1791 |
| Appl. No. | : 10/526,154 | Examiner : C. Nichols |
| Filed | : March 1, 2005 | Confirmation No. : 6656 |
| For | : METHOD AND APPARATUS FOR MAKING PALLETS | |

Commissioner for Patents
U.S. Patent and Trademark Office
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In response to the Official Action dated December 16, 2008, setting a shortened three-month statutory period for response to expire on March 16, 2009, the present Response being filed by the two-months after final date of February 17, 2009 (February 16, 2009 being a Federal holiday), Applicant respectfully requests reconsideration and withdrawal of the outstanding rejections in view of the herein-contained remarks. However, if any extension of time is necessary, this is an express request for any necessary extension of time and authorization to charge any required extension of time fee or any other fees which may be required to preserve the pendency of the present application to Deposit Account No. 19-0089.

Remarks begin on page 5 of this document.